

Certificate of Appointment

No. UA 50054524-0016

The Applicant

**KEC Electronic Industry
Development Center
3-2-2 Hikari-dai, Seika-cho
Soraku-gun, Kyoto
619-0237 Japan**

has been authorized to carry out EMC tests
by order and under supervision of TÜV Rheinland according to

EMC standards as outlined in Appendix 2.1
to this certificate

An assessment of the laboratory was conducted according to the "Procedures and
Conditions for Appointments of EMC Test Laboratories" with reference to
EN ISO/IEC 17025 by a TÜV Rheinland auditor.

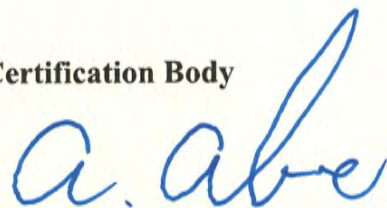
Audit Report No. 09661523-023

This certificate is valid until the next scheduled audit or up to 12 months,
at the discretion of TÜV Rheinland.

Date of issue: 23.08.2021



Certification Body



Akira Abe

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Appendix 2.1 for UA 50054524-0016, dated 23.08.2021

Standards of EMC appointment:

EN 15194, EN 50412-2-1, EN/IEC 61851-21-2, EN/IEC 61000-6-1, EN/IEC 61000-6-2,
EN/IEC 61000-6-3, EN/IEC 61000-6-4, EN/IEC 61000-6-7,
EN 12015, EN 12016, EN 12895, EN 13309,
EN 14982, EN 50121-3-2, EN 50121-4, EN 50121-5, EN 50130-4,
EN 55011, CISPR 11, EN 55012, CISPR 12, EN 55013, CISPR 13,
EN 55014-1, CISPR 14-1, EN 55014-2, CISPR 14-2, EN 55015, CISPR 15,
EN 55022, CISPR 22, EN 55024, CISPR 24, EN 55025, CISPR 25,
EN 55032, CISPR 32, EN 55035, CISPR 35, EN/IEC 60601-1-2,
EN/IEC 60945, EN/IEC 61326-1, EN/IEC 61326-2-1, EN/IEC 61326-2-2,
EN/IEC 61326-2-6, EN/IEC 61326-3-1, EN/IEC 61547, EN/IEC 61800-3,
EN/IEC 62040-2, EN/IEC 62233, IEC 62236-3-2, IEC 62236-4, IEC 62236-5,
EN 300 328, EN 300 330, EN 300 386, EN 300 440, EN 300 422-1, EN 300 422-2,
EN 300 487, EN 301 489-1, EN 301 489-3, EN 301 489-9, EN 301 489-17,
EN 301 489-19, EN 301 893, EN 303 417,
EN/IEC 61000-3-2, EN/IEC 61000-3-3, EN/IEC 61000-3-11, EN/IEC 61000-3-12,
EN/IEC 61000-4-2, EN/IEC 61000-4-3, EN/IEC 61000-4-4, EN/IEC 61000-4-5,
EN/IEC 61000-4-6, EN/IEC 61000-4-8, EN/IEC 61000-4-9, EN/IEC 61000-4-10,
EN/IEC 61000-4-11, EN/IEC 61000-4-12, EN/IEC 61000-4-13, EN/IEC 61000-4-16,
EN/IEC 61000-4-18, EN/IEC 61000-4-29, EN/IEC 61000-4-34
ISO 7637-1, ISO 7637-2, ISO 7637-3, ISO 10605, ISO 11451-2, ISO 11452-2,
ISO 11452-3, ISO 11452-4, ISO 13766, ECE-R10-04, ECE-R10-05,
JIS C 4411-2, EN ISO 13766-1, ISO 13766-1, ISO 16750-2